

FORM PTO-1449 (MODIFIED)

LIST OF PATENTS AND
 PUBLICATIONS
 APPLICANTS INFORMATION
 DISCLOSURE STATEMENT

ATTORNEY DOCKET NO.

SP03-099

SERIAL NO.

10/632364

APPLICANT: SCHROEDER J, et al.

FILING DATE 7/31/2003

GROUP: Unknown

REFERENCE DESIGNATION

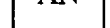

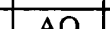

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date if Approp.
<i>TM</i>	AA	5,374,921	12/20/94	Yabe et al	_____		
<i>TM</i>	AB	5,824,127	10/20/98	Bange et al	_____		
<i>TM</i>	AC	5,879,424	3/9/99	Nishii et al	_____		
<i>TM</i>	AD	6,128,924	10/10/00	Bange et al	_____		
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-Class	Translation Yes No	
	AL							
	AM							

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

	AN	Li et al.; "Three-dimensional Hole Drilling of Silica Glass from the Rear Surface with Femtosecond Laser Pulses"; Optics Letter/Vol. 26, No. 23; December 2001; pages 1912-1914
	AO	Marcinkevicius et al.; "Femtosecond Laser-assisted Three-dimensional Microfabrication in Silica"; Optics Letter/Vol. 26, No. 5; March 2001; pages 277-279
	AP	Streltsov et al.; "Fabrication and Analysis of a Directional Coupler Written in Glass by Nanojoule Femtosecond Laser Pulses"; Optics Letters/Vol. 26, No. 1; January 2001; pages 42-43.
	AQ	Stoian et al.; Abstract of "The Dynamics of Ion Expulsion in Ultrashort Pulse Laser Sputtering of Al ₂ O ₃ "; Science Direct Web site; May 2000; 2 total pages.

EXAMINER:

DATE CONSIDERED:

04.2005

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609: draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO-1449 (MODIFIED)

LIST OF PATENTS AND
PUBLICATIONS

FOR APPLICANTS INFORMATION
DISCLOSURE STATEMENT

ATTORNEY DOCKET NO.

SP03-099

SERIAL NO.

10/632,364

APPLICANT: Schroeder, Joseph F., et al.

FILING DATE 7/31/03

GROUP: 2874

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub- Class	Filing Date if Approp.
<i>TM</i>	AA	US 6,362,453	3/26/02	Wang et al	219	121.69	3/15/99
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub- Class	Translation Yes No
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	AM						
	AN						
	AO						
	AP						
	AQ						

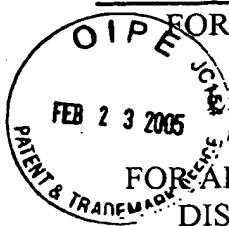
OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

	AR	
	AS	
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EXAMINER:

DATE CONSIDERED:

EXAMINER: Initial in reference considered, whether or not citation is in conformance with MPEP 609: draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

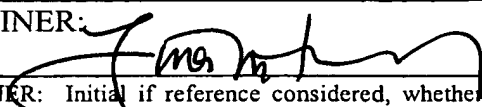


FORM PTO-1449 (MODIFIED) OFFICE OF PATENTS AND PUBLICATIONS FOR APPLICANTS INFORMATION DISCLOSURE STATEMENT	ATTORNEY DOCKET NO. SP03-099	SERIAL NO. 10/632,364
	APPLICANT: Alexander Streltsov, et al.	
	FILING DATE July 31, 2003	GROUP: 2874

REFERENCE DESIGNATION				U.S. PATENT DOCUMENTS			
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date if Approp.
ML	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						

FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub-Class	Translation Yes No
ML	AL						
	AM						
	AN						
	AO						
	AP						
	AQ						

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)		
ML	AR	XP008035862: "Three-Dimensional Hole Drilling of Silica Glass From the Rear Surface with Femtosecond Laser Pulses"; Optics Letters, Optical Society of America; Volume 26, No. 23; December 1, 2001; Pages 1912-1914
ML	AS	XP001019552: "Femtosecond Laser-Assisted Three-Dimensional Microfabrication in Silica"; Optical Letters, Optical Society of America; Volume 26, No. 5; March 1, 2001; Pages 277-279
ML	AT	
	AU	
	AV	
	AW	

EXAMINER: 	DATE CONSIDERED: 04.2005
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